

Practitioner's Docket No. LAR-16091-1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Christopher S. Welch and Daniel F. Perey

Application No.: 10/662,161

Group No.: 2812

Filed: September 11, 2003

Examiner: Andre C. Stevenson

For: Optically Stimulated Electron Emission Contamination Monitor And Method

Mail Stop Issue Fee

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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Applicant: Christopher S. Welch and Daniel F. Perey

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Invention: Optically Stimulated Electron Emission Contamination Monitor And Method

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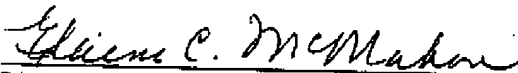
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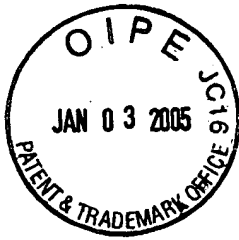
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SUBMISSION OF FORMAL DRAWINGS

The original drawings submitted with the application identified above were considered to be informal drawings. Applicant encloses herewith two sheets of formal drawings to replace the informal drawings previously submitted.

11/15/2004

Date

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